

02-14-02

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Atty. Docket No. AMAT/6394/CPI/COPPER/PJS

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Box Patent Application
 Assistant Commissioner of Patents and Trademarks
 Washington, D.C. 20231

Re: Inventor(s): Nicolay Kovarsky
 Title: APPARATUS AND METHOD FOR REMOVING CONTAMINANTS FROM
 SEMICONDUCTOR COPPER ELECTROPLATING BATHS

Transmitted herewith is the patent application identified above, including:

- ☒ Specification, claims and abstract, totaling 28 pages.
☒ Drawings totaling 4 pages, ☒ Formal ☐ Informal.
☒ Executed Declaration and Power of Attorney.
☒ Information Disclosure Statement w/ Form 1449 and References.
☒ Assignment of the invention to **Applied Materials, Inc.**
☒ Assignment Recordation Cover Sheet

FEE CALCULATION					
Fee Items	Claims Filed	Included With Basic Fee	Extra Claims	Fee Rate	Total
Total Claims	49	-20=	29	x \$18.00	\$522.00
Independent Claims	5	-3=	2	x \$84.00	\$168.00
Basic Filing Fee				\$740.00	\$740.00
TOTAL FEES					\$1,430.00

- ☒ The Commissioner is hereby authorized to charge **\$1,430.00** to Deposit Account No. **50-1074/AMAT/6394/CPI/COPPER/PJS**.
☒ The Commissioner is hereby authorized to charge any additional fees which may be required, or credit any overpayment to Deposit Account No. **50-1074/AMAT/6394/CPI/COPPER/PJS**. A duplicate copy of this transmittal is enclosed.
☒ Please address all future correspondence to:

PATENT COUNSEL
APPLIED MATERIALS, INC.
 Legal Affairs Department
 P.O. BOX 450A
 Santa Clara, CA 95052

I hereby certify that this correspondence is being deposited with the United States Postal Service as express mail in an envelope addressed to: Commissioner of Patents and Trademarks, Washington, D.C. 20231.

Express Mail Receipt No.: EV 041916281 US

Date of Deposit: 2-11-02

Signature: Robert W. Mulcahy

Respectfully submitted,

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J1062 U.S. PTO
 02/11/02

J1011 U.S. PTO
 10/074569
 02/11/02

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